

PATENT
0717-0519P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: YOSHIZAWA, Takenori Conf.:
Appl. No.: NEW Group:
Filed: November 21, 2003 Examiner:
For: SUBSTRATE CLEANING DEVICE AND SUBSTRATE
PROCESSING FACILITY

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 21, 2003

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes:

Amendments to the Specification

Remarks